Supply Chain Explorer

By the Emerging Technology Observatory

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Chemical vapor deposition tools

Chemical vapor deposition (CVD) tools create a chemical vapor that deposits films on the wafer atom-by-atom or molecule-by-molecule. CVD is the most widely used deposition technique in chip fabrication. It is used to deposit most dielectrics (a type of insulator), silicon, and some metals.

Variants

- · Atomic layer deposition tools
- High-temperature CVD tools
- Low-pressure CVD tools
- · Plasma CVD tools

Supplier countries (Variants)

- China (mainland)
- Japan
- Netherlands
- · South Korea
- · United Kingdom
- · United States

Notable supplier companies (Variants)

- · Applied Materials United States
- ASM International Netherlands
- · Kokusai Japan
- Lam Research United States
- NAURA China (mainland)
- Piotech China (mainland)
- SKY Technology Development China (mainland)
- Tokyo Electron Japan